

**Course Schedule, group M19-208****TUESDAY**

08:30 – 10:05	■ LEC	Opt	Military Training (2020-09-01 – 2020-12-15) 📍 DOT
10:15 – 16:05	■ SEM	Opt	Military Training (2020-09-01 – 2020-12-15) 📍 DOT

**WEDNESDAY**

10:15 – 11:00	■ LEC		Applications of High-frequency Plasma in Technology 🎓 Ivanov V.A. 📍 DOT
11:05 – 12:40	■ SEM		Applications of High-frequency Plasma in Technology 🎓 Ivanov V.A. 📍 DOT

**THURSDAY**

10:15 – 11:50	■ SEM		Physics Seminar in English 🎓 Pisarev A.A. 📍 DOT
12:45 – 14:20	■ LEC		Management of Intellectual Property (2020-09-03 – 2020-09-24) 🎓 Yushkov E.S. 📍 DOT
	■ SEM		Management of Intellectual Property (2020-10-01 – 2020-12-17) 🎓 Yushkov E.S. 📍 DOT

**FRIDAY**

17:05 – 18:40	■ LEC		Methods of surface analysis (2020-09-04 – 2020-09-25) 🎓 Sadovskiy Y.A. 📍 DOT
	■ SEM		Methods of surface analysis (2020-10-02 – 2020-10-23) 🎓 Sadovskiy Y.A. 📍 DOT
	■ SEM		Methods of surface analysis (2020-10-30 – 2020-12-18) 🎓 Sadovskiy Y.A. 📍 DOT
18:45 – 19:30	■ LEC		Plasma Spectroscopy 🎓 Zimin A.M., Shevchenko A.A., Alieva A.I. 📍 DOT
19:35 – 21:10	■ SEM		Plasma Spectroscopy 🎓 Zimin A.M., Shevchenko A.A., Alieva A.I. 📍 DOT